

EXPEDITED PROCEDURE – EXAMINING GROUP 1725

S/N 10/823,314

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Neo C. Peng et al.	Examiner:	Samuel M Heinrich
Serial No.:	10/823,314	Group Art Unit:	1725
Filed:	April 13, 2004	Docket No.:	303.772US2
Title:	WAFER DICING DEVICE AND METHOD		

AMENDMENT & RESPONSE UNDER 37 C.F.R. 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

In response to the Final Office Action mailed July 13, 2006, please amend the application as follows: